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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/046,497	10/26/2001	Er-Xuan Ping	MTI-31041-A	8624
22202	7590	03/14/2007	EXAMINER	
WHYTE HIRSCHBOECK DUDEK S C 555 EAST WELLS STREET SUITE 1900 MILWAUKEE, WI 53202			LE, THAO X	
)			ART UNIT	PAPER NUMBER
			2814	
SHORTENED STATUTORY PERIOD OF RESPONSE	MAIL DATE	DELIVERY MODE		
3 MONTHS	03/14/2007	PAPER		

Please find below and/or attached an Office communication concerning this application or proceeding.

If NO period for reply is specified above, the maximum statutory period will apply and will expire 6 MONTHS from the mailing date of this communication.

Office Action Summary	Application No.	Applicant(s)	
	10/046,497	PING ET AL.	
	Examiner Thao X. Le	Art Unit 2814	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --
Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) Responsive to communication(s) filed on 05 January 2007.
- 2a) This action is **FINAL**. 2b) This action is non-final.
- 3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) Claim(s) 143-155, 167-193 and 196-232 is/are pending in the application.
- 4a) Of the above claim(s) 149-155, 170-172, 176-181, 190-193, 196 and 198-226 is/are withdrawn from consideration.
- 5) Claim(s) _____ is/are allowed.
- 6) Claim(s) 143-148, 167-169, 173-175, 182-189, 197, 224 and 227-231 is/are rejected.
- 7) Claim(s) _____ is/are objected to.
- 8) Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) The specification is objected to by the Examiner.
- 10) The drawing(s) filed on _____ is/are: a) accepted or b) objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) All b) Some * c) None of:
 1. Certified copies of the priority documents have been received.
 2. Certified copies of the priority documents have been received in Application No. _____.
 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

1) <input checked="" type="checkbox"/> Notice of References Cited (PTO-892)	4) <input type="checkbox"/> Interview Summary (PTO-413)
2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail Date. _____
3) <input type="checkbox"/> Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date _____	5) <input type="checkbox"/> Notice of Informal Patent Application (PTO-152)
	6) <input type="checkbox"/> Other: _____

DETAILED ACTION

Election/Restrictions

1. Applicant's election of Species Subgroup "b"; fig. 2A-2F corresponding generic claims 143, 173, 182, 186, 197, 227, 229 and 230 in the reply filed on 05 Jan. 2007 is acknowledged; thus claims 143-148, 167-169, 173-175, 182-189, 197, 224, 227-231 are being considered, while claims 149-155, 170-172, 176-181, 190-193, 196, 198-226, and 232 are withdrawn from consideration. Because applicant did not distinctly and specifically point out the supposed errors in the restriction requirement, the election has been treated as an election without traverse (MPEP § 818.03(a)).

Claim Rejections - 35 USC § 102

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

3. Claims 143-144, 147, 167, 169-170, 173, 175, 182-189, 197, 227-231 are rejected under 35 U.S.C. 102(b) as being anticipated by or, in the alternative, under 35 U.S.C. 103(a) as obvious over JP401286361 to Matsumoto.

Regarding claims 143, 173, 182, 186, 197, 227, 229 and 230, Matsumoto discloses a semiconductor structure in fig. 3, comprising at least two overlying faceted layers 4/6 of single crystal epitaxial silicon (ES), each ES layer comprising a faceted

surface comprising a plurality of facets, fig. 3, and sidewalls with insulative materials 3 thereover, and an uppermost faceted layer of at least two overlying layers of ES having a layer of an insulative material 5 over the faceted surface of uppermost layer of ES, wherein the structure is situated on a substrate 1 in a vertical orientation, fig. 3 and attached abstract and constitution.

With respect to the "single crystal", Matsumoto uses the SEG (selective epitaxial growth) that is a process that deposit single crystal silicon layers only on the exposed silicon substrate surface within the opening in the dielectric mask.

Such definition can be found in Lee (US6228733) in col. 1 lines 20-25. When the structure recited in the reference is substantially identical to that of the claims, claimed properties or functions are presumed to be inherent. Or where the claimed and prior art products are identical or substantially identical in structure or composition, or are produced by identical or substantially identical processes, a *prima facie* case of either anticipation or obviousness has been established. *In re Best*, 195 USPQ 430, 433 (CCPA 1977) and MPEP 2112.01.

Regarding to claims 144, 147, Matsumoto discloses the semiconductor structure wherein the insulative crystal 5 comprises an oxide.

Regarding claims 167, 169, 175, 183-185, 187-189, Matsumoto discloses the semiconductor structure being a component of a transistor, and being a S/D diffusion region, fig. 1-3.

Regarding to claims 173, Matsumoto discloses a semiconductor structure in fig. 3, comprising at least two overlying faceted layers 4/6 of single crystal epitaxial silicon

(ES) including an uppermost faceted layers of single crystal ES 6; each of said faceted layers comprising a faceted top surface comprising a plurality of facets, and insulated sidewalls, and the uppermost faceted layer of ES having an insulated top surface; the structure is situated on a substrate in a vertical orientation, wherein the structure being a component of a transistor, fig. 1-3.

With respect to the “single crystal”, Matsumoto uses the SEG (selective epitaxial growth) that is a process that deposit single crystal silicon layers only on the exposed silicon substrate surface within the opening in the dielectric mask. Such definition can be found in Lee (US6228733) in col. 1 lines 20-25. When the structure recited in the reference is substantially identical to that of the claims, claimed properties or functions are presumed to be inherent. Or where the claimed and prior art products are identical or substantially identical in structure or composition, or are produced by identical or substantially identical processes, a *prima facie* case of either anticipation or obviousness has been established. *In re Best*, 195 USPQ 430, 433 (CCPA 1977) and MPEP 2112.01.

Regarding to claim 231, Matsumoto discloses a semiconductor structure in fig. 3, wherein an uppermost silicon layer 6 comprises conductivity enhancing dopant; see abstract and constitution.

Claim Rejections - 35 USC § 103

4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

5. Claims 145-146, 148, 168, and 174, are rejected under 35 U.S.C. 103(a) as being unpatentable over JP401286361 to Matsumoto in view of US 5483094 to Sharma et al.

Regarding claims 145-146 and 148, Matsumoto does not expressly disclose the thickness of the insulative layer comprises silicon nitride having thickness about 5 to 20 nm or 2 to 5 nm.

However, Sharma reference discloses an insulative layer 41/61 comprises silicon oxide and/or silicon nitride, col. 5 line 29-32, has a general thickness in fig. 12. Accordingly, it would have been obvious to one of ordinary skill in art to use the silicon nitride teaching Sharma in Matsumoto device in the range as claimed, because it has been held that where the general conditions of the claims are disclosed in the prior art, it is not inventive to discover the optimum or workable

range by routine experimentation. See *In re Aller*, 220 F.2d 454, 105 USPQ 233, 235 (CCPA 1955), and also because such material substitution would have been considered a mere substitution of art-recognized equivalent values, MPEP 2144.06.

Regarding claims 168 and 174, Matsumoto does not disclose the semiconductor structure being a transistor gate.

A recitation of 'being a transistor gate' of the claimed invention does not result in a structural difference between the claimed invention and the prior art, thus claimed invention is only an art recognized suitability for an intended purpose, MPEP 2144.07. Matsumoto structure is capable of being a transistor gate.

Response to Arguments

6. Applicant's arguments filed Nov. 2, 2006 have been fully considered but they are not persuasive. The Applicant requests a written text in Matsumoto that describes a second SEG layer. The fig.3 of Matsumoto shows two SEG layers 4 and 6. No additional text is necessary. It is apparent that the Applicant's argument replies on the different method between Matsumoto and present invention. However, the patentability of a product does not depend on its method of production. If the product in the product-by-process claim is the same as or obvious from a product of the prior art, the claim is unpatentable even though the prior product was made by a different process." *In re Thorpe*, 777 F.2d 695, 698, 227 USPQ 964, 966 (Fed. Cir. 1985), MPEP 2113.

Conclusion

7. All claims are drawn to the same invention claimed in the application prior to the entry of the submission under 37 CFR 1.114 and could have been finally rejected on the grounds and art of record in the next Office action if they had been entered in the application prior to entry under 37 CFR 1.114. Accordingly, **THIS ACTION IS MADE FINAL** even though it is a first action after the filing of a request for continued examination and the submission under 37 CFR 1.114. See MPEP § 706.07(b).
Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

8. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thao X. Le whose telephone number is (571) 272-1708. The examiner can normally be reached on M-F from 8:00 AM - 4:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael M. Fahmy can be reached on (571) 272 -1705. The fax phone

number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

09 Mar. 2007



THAO X. LE
PRIMARY PATENT EXAMINER